

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Tois et al.
App. No	:	10/678,766
Filed	:	October 2, 2003
For	:	METHOD OF GROWING OXIDE THIN FILMS
Examiner	:	Matthew J. Song
Art Unit	:	1792
Conf #	:	1629

**RESPONSE TO OFFICE ACTION****Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action that was mailed on January 24, 2008 and is accompanied by a request for a three-month extension of time. Applicants respectfully request consideration of the following remarks.

**Listing of the Claims** begins on page 2 of this paper.

**Summary of Interview** begins on page 6 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.